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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP05/01057 01/27/2005

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2004-020157 01/28/2004

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***

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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	7	20	4
Verified and JOSEPH ALBERT MILLER, JR/ Examiner's Signature		Initials				

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**TITLE**

Method for cleaning process chamber of substrate processing apparatus, substrate processing apparatus, and method for processing substrate

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